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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Kuan-Lun Chang

Group Art Unit: 2823

Serial No.: 10/729,034

Examiner: Garcia, Joannie A.

Filed: Dec 4, 2004

In Response to Office Action

Dated: Jan 11, 2005

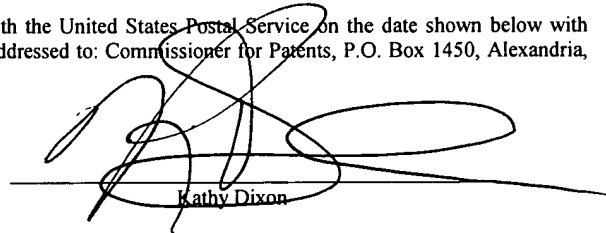
For: HIGH DENSITY MIM CAPACITOR STRUCTURE AND FABRICATION PROCESS

Attorney Docket No.: 67,200-1157 (2003-0114)

Certificate of Mailing

I hereby certify that this paper is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: Feb. 2, 2005



Kathy Dixon

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Alexandria, VA 22313-1450

In response to a restriction requirement mailed by the Examiner mailed on January 11, 2005, the Applicants hereby elect with traverse, the prosecution of Group I, device claims 1-11.